

L Number	Hits	Search Text	DB	Time stamp
-	398	(trench same etch\$3 same (silicon-on-insulator or SOI))	USPAT	2003/06/20 17:34
-	45	bosch and (etch\$3 with passiv\$5)	USPAT	2003/08/04 14:12
-	287	bosch and (silicon and etch\$3).ab.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/08/06 13:57
-	22	bosch and (silicon and etch\$3).ab. and waveguide\$1	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/08/06 13:46
-	454	bosch and waveguide\$1	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/08/06 14:03
-	9	waveguide\$1 same smoothness same (nanometers or nm)	USPAT	2003/08/06 16:21
-	21	waveguide\$1 same smoothness same (etch\$3)	USPAT	2003/08/06 16:20
-	85	waveguide\$1 same roughness same (etch\$3)	USPAT	2003/08/06 16:21
-	42	waveguide\$1 same roughness same (nanometers or nm)	USPAT	2003/08/06 16:20
-	19	waveguide\$1 with roughness with (etch\$3)	USPAT	2003/08/06 17:16
-	1	waveguide\$1 with smoothness with (nanometers or nm)	USPAT	2003/08/06 16:23
-	35	waveguide\$1 with roughness with (etch\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/08/06 16:23
-	16	waveguide\$1 with roughness with (nanometers or nm)	USPAT	2003/08/06 16:53
-	0	bocsh and HBr	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/08/06 17:01
-	34	bosch and HBr	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/08/06 17:01
-	1	waveguide\$1 and bosch and (roughness with (etch\$3))	USPAT	2003/08/06 17:17
-	4	waveguide\$1 and bosch and (roughness and (etch\$3))	USPAT	2003/08/06 17:17
-	14266	robert adj bosch	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/08/06 18:59
-	1236	(robert adj bosch) and ((light adj guide) or optical or waveguide or etch\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/08/06 19:04
-	485	(robert adj bosch) and ((light adj guide) or optical or waveguide or etch\$3 or silicon).ab.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/08/06 19:03
-	5	(robert adj bosch).in.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/08/06 19:04